

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/598,502 Confirmation No. 6549
Applicant : Yuichiro Nakamura et al.
371 Filed : September 1, 2006
Art Unit : 1793
Examiner : Mark L. Shevin
Customer No. : 00270
Title : SPUTTERING TARGET WITH FEW SURFACE DEFECTS,
AND SURFACE PROCESSING METHOD THEREOF

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment timely submitted in response to a non-final Office Action dated June 17, 2010. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.